

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of

Minoru KATAYAMA et al.

Application No.:

09/690,590

Filed:

October 18, 2000

Group Art Unit: 2856

Examiner:

Docket No.:

107612

For:

SURFACE TEXTURE MEASURING MACHINE, LEVELING DEVICE FOR

SURFACE TEXTURE MEASURING MACHINE AND ORIENTATION-ADJUSTING METHOD OF WORKPIECE OF SURFACE TEXTURE MEASURING MACHINE

LARGE ENTITY REQUEST FOR **CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination and entry and consideration of the Amendment under 37 C.F.R. §1.114 filed herewith. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 135841 in the amount of \boxtimes \$740.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No.

15-0461. Two duplicate copies of this page are enclosed.

740.00 OP

Respectfully submitted,

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JAO:RJK/sld

11/06/2002 SDENBOB1 00000083 09690590

Date: November 5, 2002

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DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461



PATENT APPLICATION LAYES

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M. Cygan

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AMENDMENT UNDER 37 C.F.R. §1.114

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AMENDMENT UNDER 37 C.F.R. §1.114

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Prior to continued examination, in reply to the August 8, 2002, Office Action and the interview held October 29, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claims 1, 4 and 8 as follows:

(Twice Amended) A surface texture measuring machine for measuring a 1. surface texture of a workpiece held on a workpiece orientation adjustment stage, the workpiece having an edge line, the workpiece orientation adjustment stage being movable in a measurement direction (X-axis direction) and in a direction (Y-axis direction) orthogonal with the X-axis direction within a horizontal Mane and rotatable in a X-Y plane, the workpiece orientation adjustment stage being capable of seesawing in a direction (Z-axis direction) orthogonal with the X-axis direction within a perpendicular plane, and the surface texture of the workpiece being scanned by a sensor movable in the X-axis direction after adjusting orientation of the workpiece orientation adjustment stage, the surface texture measuring machine comprising: